

APPLICANT'S ART CITATION (Use several sheets if necessary)		Application 09/651,770		OFGS File No. P/3541-7	
		Applicant Tatsuji HIGUCHI et al.			
		Filing Date August 30, 2000		Group Art Unit 2623 <i>2612</i>	

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U.S. PATENT DOCUMENTS						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-					
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
<i>h</i>	2-172365	07-1990	Japan	—	—	X (see JP Office Action)	
<i>h</i>	62-117883	07-1987	Japan	—	—	X (see JP Office Action)	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
<i>h</i>		Japanese Office Action mailed December 2, 2003.
<i>h</i>		English-language transaction of Japanese Office Action mailed December 2, 2003.

Examiner <i>[Signature]</i>	Date Considered <i>8/18/04</i>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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